



ITW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 4026**
Sumio IJIMA et al. : Attorney Docket No. 2005_0065A
Serial No. 10/521,575 : Group Art Unit 1633
Filed January 18, 2005 : Examiner Robert M. Kelly
STRUCTURES SELECTING METHOD : **Mail Stop: AMENDMENT**
FOR CARBON NANOTUBES BY
LIGHT IRRADIATION

SUPPLEMENTAL RESPONSE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:


Further to the response filed on April 14, 2008, there is submitted herewith another copy of the English translation of applicants' Japanese priority application with Translator's Statement of accuracy. The previously filed translation did not include the Translator's Statement.

Favorable action is respectfully requested.

Respectfully submitted,

Sumio IJIMA et al.

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO 23-0975

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July 10, 2008

TRANSLATOR'S STATEMENT

Assistant Commissioner for Patents,
Washington, D.C.

Sir:

I, Toshio NISHIZAWA, hereby certify:

That I am thoroughly familiar with the Japanese and English languages;

That I am competent to serve as a translator of Japanese documents into English; and

That the attached document represents a true English translation of Japanese application

2003-000718, filed January 6, 2003.

Signed this 25 day of March, 2008.

Toshio Nishizawa
Translator